



BSI Standards Publication

Semiconductor devices – Micro-electromechanical devices

Part 33: MEMS piezoresistive pressure-sensitive device

National foreword

This British Standard is the UK implementation of IEC 62047-33:2019.

The UK participation in its preparation was entrusted to Technical Committee EPL/47, Semiconductors.

A list of organizations represented on this committee can be obtained on request to its secretary.

This publication does not purport to include all the necessary provisions of a contract. Users are responsible for its correct application.

© The British Standards Institution 2019
Published by BSI Standards Limited 2019

ISBN 978 0 580 97390 1

ICS 31.080.99; 31.140

Compliance with a British Standard cannot confer immunity from legal obligations.

This British Standard was published under the authority of the Standards Policy and Strategy Committee on 30 April 2019.

Amendments/corrigenda issued since publication

Date	Text affected
------	---------------
